

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Young Hoon PARK, et al. )  
Serial No.: 10/511,883 ) Group Art Unit: 1763  
Filed: October 19, 2004 )  
For: APPARATUS AND METHOD FOR ) Examiner:  
DEPOSITING THIN FILM ON WAFER ) ) NG, James Wai Heung  
USING REMOTE PLASMA )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This Amendment is submitted in response to the Office Action dated April 5, 2007.  
Please amend the Application as follows: